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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Inventors: Jiping Li and Peter G. Borden  
Assignee: Applied Materials, Inc.  
Title: Evaluating Sidewall Coverage In A Semiconductor Wafer  
Serial No.: 09/788,273 Filing Date: Feb. 16, 2001  
Examiner: Michelle Estrada Group Art Unit: 2823  
Docket No.: BOX009 US Confirmation No: 6335

Santa Clara, California  
May 12, 2004

COMMISSIONER FOR PATENTS  
P.O. Box 1450  
Alexandria, VA 22313-1450

AMENDMENT

Dear Sir:

In response to Office Action dated February 12, 2004, please amend the above-identified application as follows.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks/Arguments** begin on page 11 of this paper.

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01 FC:1201  
02 FC:1202

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